

Docket No.: 49959-118

HY 1-31-01
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Lizhong Sun, et al.

Serial No.: 09/645,690 -

Filed: August 24, 2000 -

For: CU CMP POLISHING PAD CLEANING -



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Group Art Unit: 2812

Examiner: unknown

TC 2800 MAIL ROOM

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT


Commissioner for Patents
Washington, DC 20231

Dear Sir:

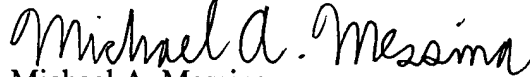
In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to pending applications Serial No. 09/163,582 and Serial No. 09/359,141, which contain similar subject matter to the above-referenced application. A reference cited in these applications is listed on the attached form PTO-1449.

The identification of these U.S. Patent Applications is not to be construed as a waiver of secrecy as to that application now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted, 

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